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Docket No.: ISH-0230  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
TAKENO, Hiroshi et al.

Application No.: 10/530,557

Confirmation No.: 8829

Filed: April 7, 2006

Art Unit: 1765

For: ANNEALED WAFER AND METHOD FOR  
MANUFACTURING THE SAME

Examiner: Not yet assigned

**STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

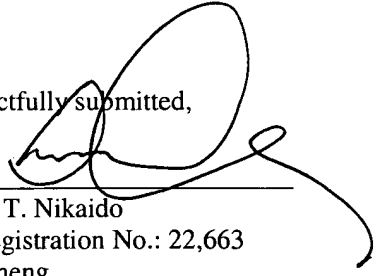
Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 18-0013, under Order No. ISH-0230 from which the undersigned is authorized to draw.

Dated: October 23, 2006

Respectfully submitted,

By   
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